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** CONTINUING DATA ***** This application is a 371 of PCT/JP03/08577 07/07/2003				
** FOREIGN APPLICATIONS ***** JAPAN 2002-197140 07/05/2002				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>[Signature]</i> <i>FM</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 15	TOTAL CLAIMS 6
				INDEPENDENT CLAIMS 3
ADDRESS 26418				
TITLE Method of producing silicon monocrystal				
FILING FEE RECEIVED 1390	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	